

ALFA metrology and test-beam analysis

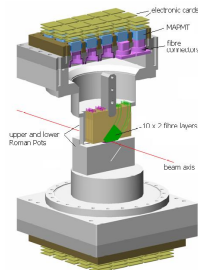
Adrian Driewer

September 10th 2009

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 - Setup
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- 2 Test-beam in August '08
 - Setup
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 - Good plate
 - Bad plate
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Luminosity measurements

2 detectors that measure the luminosity for ATLAS:
ALFA (Absolute Luminosity for ATLAS)



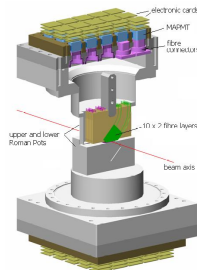
Luminosity measurements

2 detectors that measure the luminosity for ATLAS:

ALFA (Absolute Luminosity for ATLAS)

&

LUCID (Luminosity measurement using Cherenkov Integrating Detector)



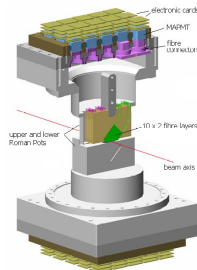
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+ Absolute measurement

- Luminosity $< 10^{27} \text{ cm}^{-1} \text{ s}^{-1}$

+ Luminosity up to $10^{34} \text{ cm}^{-1} \text{ s}^{-1}$

- relative measurement

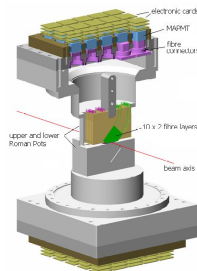
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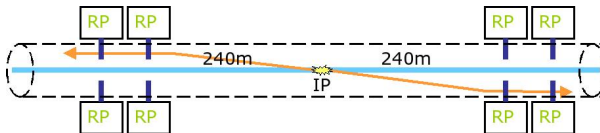


- + Absolute measurement
- Luminosity $< 10^{27} \text{ cm}^{-2} \text{ s}^{-1}$

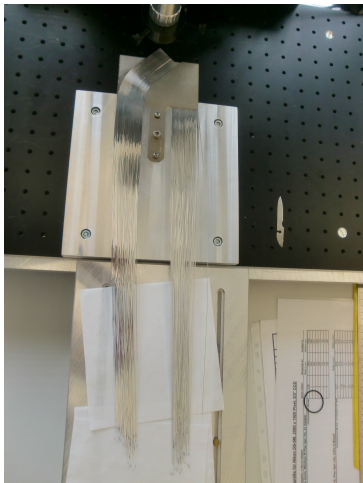
- + Luminosity up to $10^{34} \text{ cm}^{-2} \text{ s}^{-1}$
- relative measurement

⇒ Calibrate LUCID with ALFA at low luminosity runs

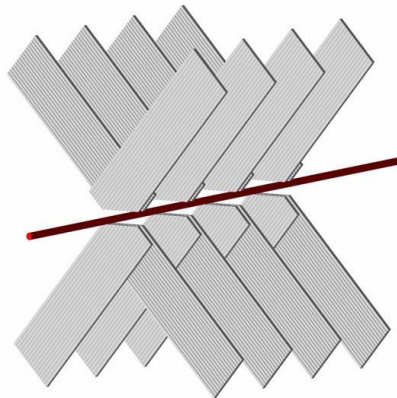
Where to find the ALFA detector



The detector

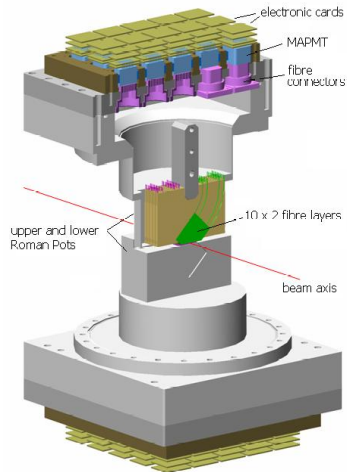
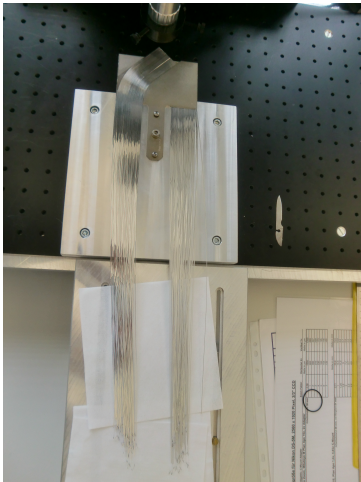


A detector on the measuring setup



4 detectors in a row

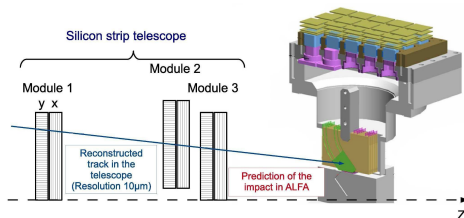
The detector



A detector on the measuring setup

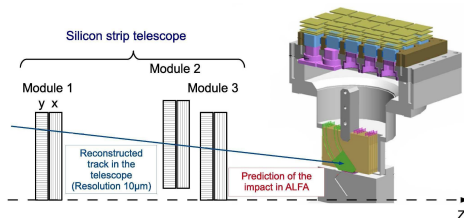
Detectors installed in a roman pot

Test-beam setup

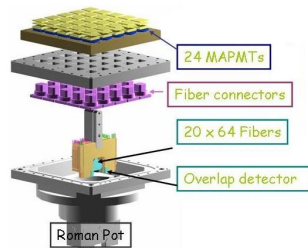


Scheme of the prototype-2 roman pot in the SPS test beam line with a silicon strip telescope

Test-beam setup



Scheme of the prototype-2 roman pot in the SPS test beam line with a silicon strip telescope



Schematic view how the detectors are connected to the read out electronics

Layer configurations

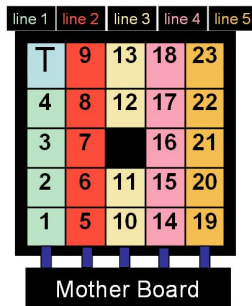
two different readout systems

- test board from LAL Orsay:
able to read out two rows of 5 PMTs
- motherboard made in Lund as a version of the final ALFA electronics:
read out of all 23 PMTs

Layer configurations

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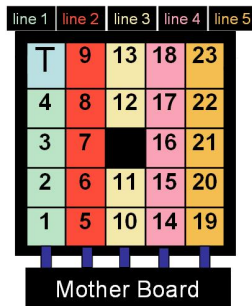
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measured lines

1&2 4&5, 3&5, 2&4, 2&5, 1&5

Used configurations

several threshold cuts to generate digital signals (DAC)

1000, 1500, 2000, 2500, 3000

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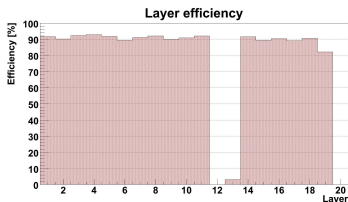
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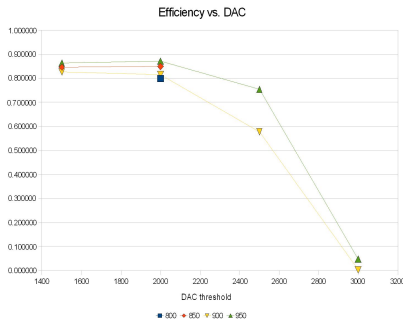
some overall gain factors for all channels (GAIN)

8, 16, 24, 30

Layer efficiency

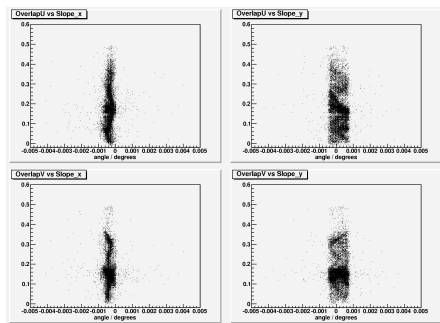


Layer efficiency for basic sample:
 HV=900V, DAC=2000,
 Gain=16



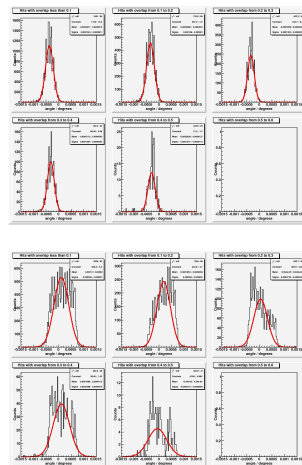
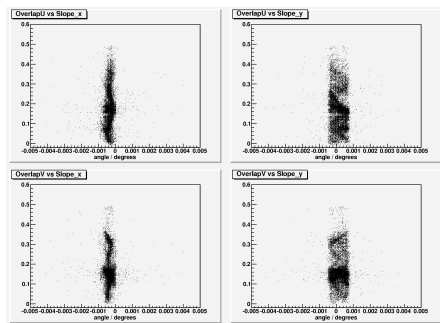
Layer efficiency dependence on the
 threshold and high voltage

Angle dependency



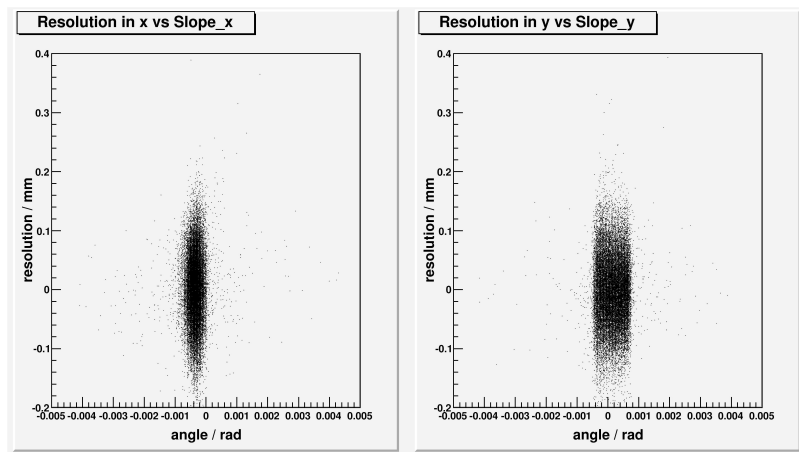
The angle dependency of the size of the overlap region

Angle dependency



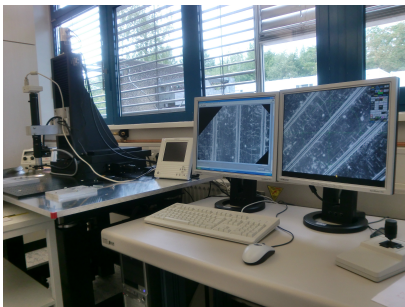
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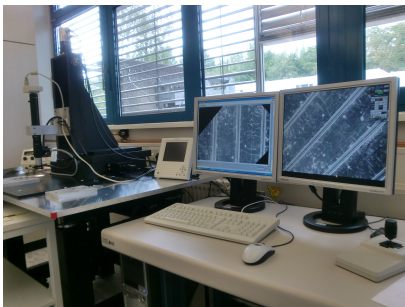
The angle dependency of the resolution

The measuring setup

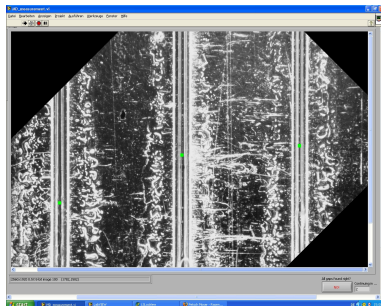


The measuring setup

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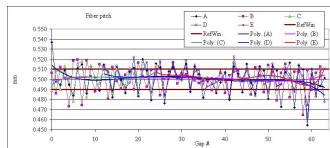


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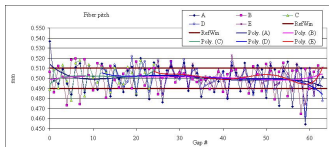
Screenshot during the measurement

Example of a measured metrology

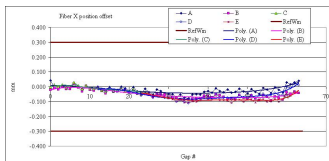


- The pitch between two gaps
- Reference: $500\mu m$

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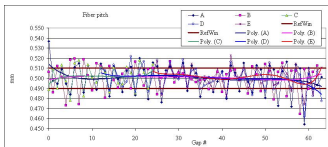


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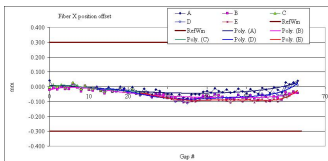


- Offset of the measured value from the reference

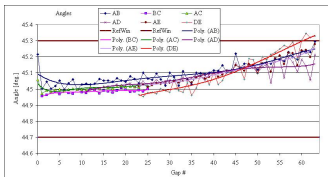
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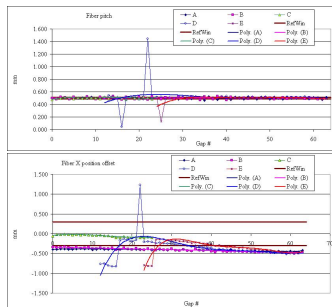


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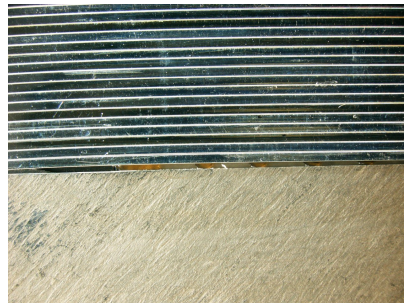
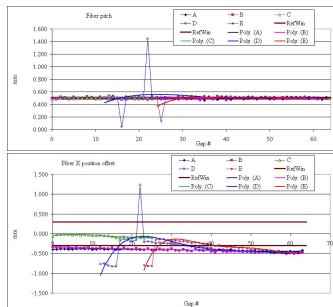
- Angle of the gaps
- Reference: 45°

Bad plate: A2-2 Pl.4



Apparently something went wrong

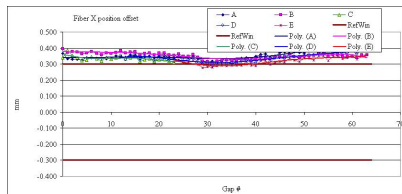
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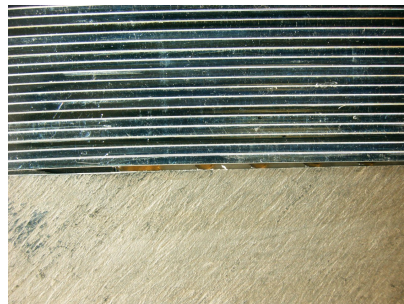
Apparently something went wrong

→ a $\sim 300\mu m$ gap!

Bad plate: A2-2 Pl.4



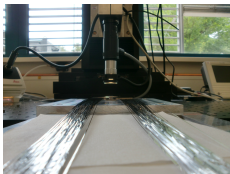
Manual measuring proved the size of the gap



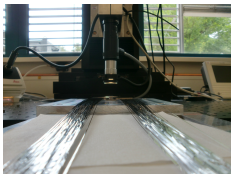
Picture of the $\sim 300\mu m$ gap

Summary

- The metrology of 20 ALFA detectors was measured.

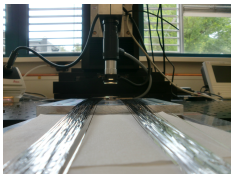


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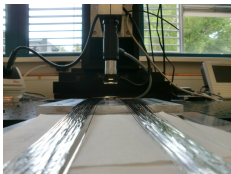
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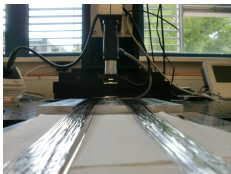
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Thank you for your attention!